MOOV

Configuration check sheet

1	Check Date		Inspector		
2	End User	TOSHIBA			
3	Machine Model	NSR-2005i8A	Serial Number		
4	Electric source	(without/with) NEMA BOX / For (CVCF/UPS) / NEMA Switch(none/1/2)			
5	Chamber Type	Maker	ASAHI / SENDAI	Production date	1994. 01
		S/N		Model	S810
6	Chamber Size	1750		Chamber EPROM Ver.	
7	SET Temprature	Chamber : ℃	LATC(LLTC): ℃	IATC: ℃	
	Reticle Microscope	Fixed ( )/ Variable (mm to mm) / setting size ( )			
8	Main Software version		Computer Type	PDP11(73/93) / NEST ( )	
9	ROM Version	ST-	XY-	EP-	
		PA-	WF-	CE-	
		WA-	LC-	RA-	
		RL-			
10	HP LASER	5517A / 5517B / 5517C	LSA LASER	5mW / 10mW	
11	ITV Camera	Nikon Original Type / Nikon New Type / Custom eng. / Other ( )			
12	Wafer Size	2inch / 2.5inch / 3inch / 4inch / 6inch / 8inch			
13	Wafer Condition	Sapphire / Silicon / Other( )			
14	OF Detection Type	Nikon Original Type / Omron type / Keyence type			
15	Wafer Loader Type	Type1 / Type2 (A1 / A3)			
16	Wafer Carrier Table	Left / Right / Extra		In-line	no / yes (right/left)
17	Reticle Size	5inch(32mm / 26mm / 18mm) /6inch		FIA	no / yes
18	Reticle Library Slot	Main : (23) slot / Ext. LIB (16) slot			
19	PPD /PD/ Extension LIB	PPD (no/yes) PD(no/yes) Extension LIB(no/yes)			
20	Rack Type	Normal (Right / Left) / Special			
21	NOTE	Wafer Stage 8-6"			